

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Kyoichi KINOSHITA; Takashi YOSHIDA; Tomohei SUGIYAMA; Hidehiro KUDO; and Eiji KONO

Serial No.: TBA

Group Art Unit: TBA

Filed: Herewith

Examiner: TBA

For: RADIATOR SYSTEM, RADIATING METHOD, THERMAL BUFFER,  
SEMICONDUCTOR MODULE, HEAT SPREADER AND SUBSTRATE

**INFORMATION DISCLOSURE STATEMENT**

**Mail Stop Patent Application**

Commissioner for Patents

PO Box 1450

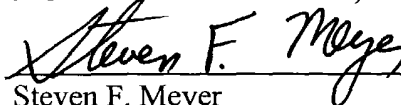
Alexandria, Virginia 22313-1450

Sir:

Pursuant to Rule 56, applicant hereby calls the attention of the Patent Office to the references listed on the attached Form PTO 1449. Copy(ies) of these references ☒ are attached ☐ were filed in related application U.S. Serial No(s) \_\_\_\_\_, filed \_\_\_\_\_, respectively.

- ☐ This document is being filed within three (3) months of the filing date of the application
- ☐ Please charge the \$180 fee to Deposit Account No. 13-4500, Order No. \_\_\_\_\_.
- ☒ This document is being concurrently filed with the above-identified application
- ☐ This document is being concurrently filed with an Request for Continued Examination (RCE)
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Respectfully submitted,  
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Dated: July 7, 2003

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